

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q73500

Masahiro AMEMIYA, et al.

Appln. No.: 10/538,929

Group Art Unit: 1751

Confirmation No.: 5996

Examiner: UNKNOWN

Filed: June 13, 2005

For: CLEANING AGENT COMPOSITION, CLEANING AND PRODUCTION METHODS FOR
SEMICONDUCTOR WAFER, AND SEMICONDUCTOR WAFER

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

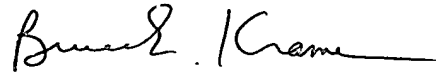
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of two months, extending the time for responding to the Office Action of February 22, 2006 to June 22, 2006.

A check for the statutory fee of \$450.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,



Bruce E. Kramer
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WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: June 22, 2006

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